



IFW

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

Applicant: Kim, et al. Docket No.: 2003 P 53738 US  
Serial No.: 10/720,450 Art Unit: 2891  
Filed: November 24, 2003 Examiner: Caridad Everhart  
For: MIM Capacitor Structure and Method of Fabrication

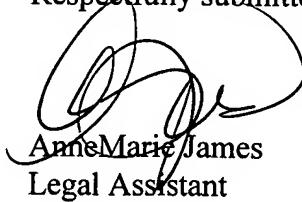
**Certificate of Mailing via First Class Mail (37 C.F.R. § 1.8(a))**

Date of Deposit: September 16, 2005

I hereby certify that the below listed correspondence is being deposited with the United States Postal Service on the date indicated above as first class mail in an envelope addressed to: Mail Stop Amendment, Commissioner for Patents, P. O. Box 1450, Alexandria, VA 22313-1450.

Certificate of Mailing via First Class Mail (1 page)  
Amendment Transmittal Letter (1 original and 1 copy)  
Amendment (12 pages)  
Information Disclosure Statement (1 original and 1 copy)  
Form PTO/SB/08A (1 page), with 16 references cited  
Copy of (1) cited reference  
Return Postcard

Respectfully submitted,



Anne Marie James  
Legal Assistant

Slater & Matsil, L.L.P.  
17950 Preston Rd., Suite 1000  
Dallas, TX 75252  
Tel: 972-732-1001  
Fax: 972-732-9218